

Notice of References Cited	Application/Control No. 10/673,667		Applicant(s)/Patent Under Reexamination SEMPOWSKI ET AL.	
	Examiner Xiaozhen Xie		Art Unit 1646	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,544,749 B1	04-2003	Kim, Kyung Jin	435/7.1
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

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